



Art Unit : 1742  
Docket No. : 52433/766

IFW 1742

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Y. USHIGAMI et al.  
Serial No. : 10/500,994  
Filed : January 12, 2005  
For : METHOD FOR MANUFACTURING GRAIN-ORIENTED SILICON  
STEEL SHEETS WITH MIRROR-LIKE SURFACE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**TRANSMITTAL LETTER**

SIR:

Transmitted herewith is an Amendment/Response in the above-identified patent application.

☒ No additional fee is required.

The fee has been calculated as shown below.

				SMALL ENTITY		OTHER THAN A SMALL ENTITY	
CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. OR FEE	RATE	ADDIT. FEE	
TOTAL 15 MINUS 20 = 0			x6=	\$	x18 =	\$	0.00
INDEP. 5 MINUS 5 = 0			x18=	\$	x84 =	\$	0.00
[ ] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM			x60=	\$	x280=	\$	0.00
TOTAL							
ADDIT. FEE				\$	OR	\$	0.00

☒ The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 which may be required to Deposit Account 11-0600. A duplicate of this paper is enclosed.

☐ A petition for a \_\_\_\_ ( ) month extension of time and Deposit Account authorization to cover the extension fee are enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 8, 2005.

John J. Kelly, Jr.  
John J. Kelly, Jr. Reg. No. 29,182

Respectfully submitted,

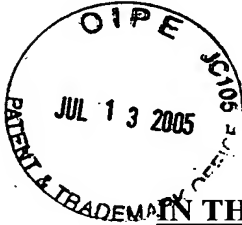
KENYON & KENYON

By: John J. Kelly, Jr.  
John J. Kelly, Jr.  
Reg. No. 29,182

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*John J. Kelly, Jr.*

John J. Kelly, Jr. Reg. No.: 29,182



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**AMENDMENT**

SIR:

Entry of the present amendment to the specification of the above-identified patent application is respectfully requested.